



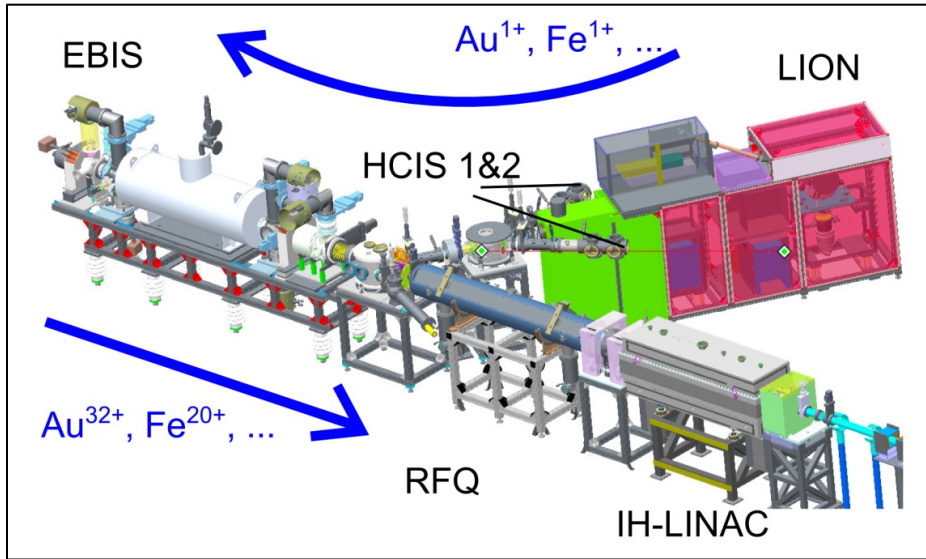
Development of Laser Ion Source

Shunsuke Ikeda

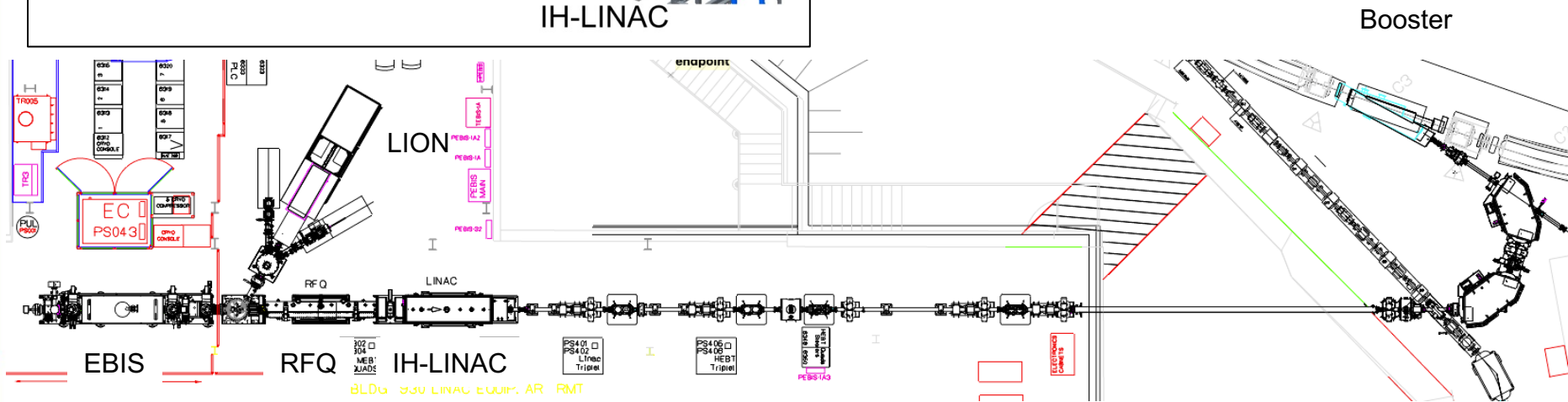
9/9/2022



Pre-injector: LION and EBIS



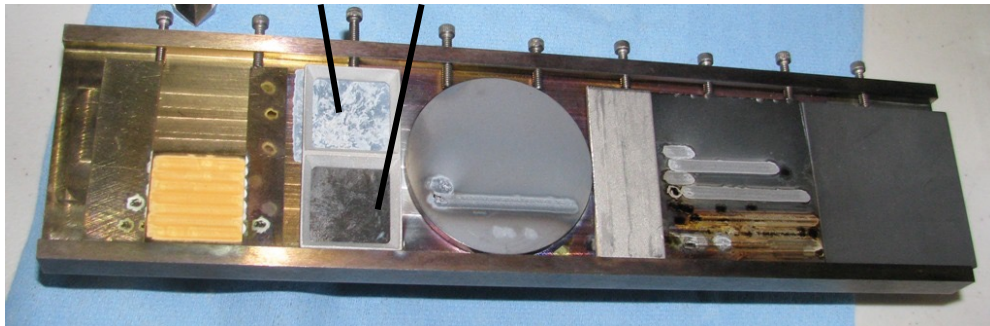
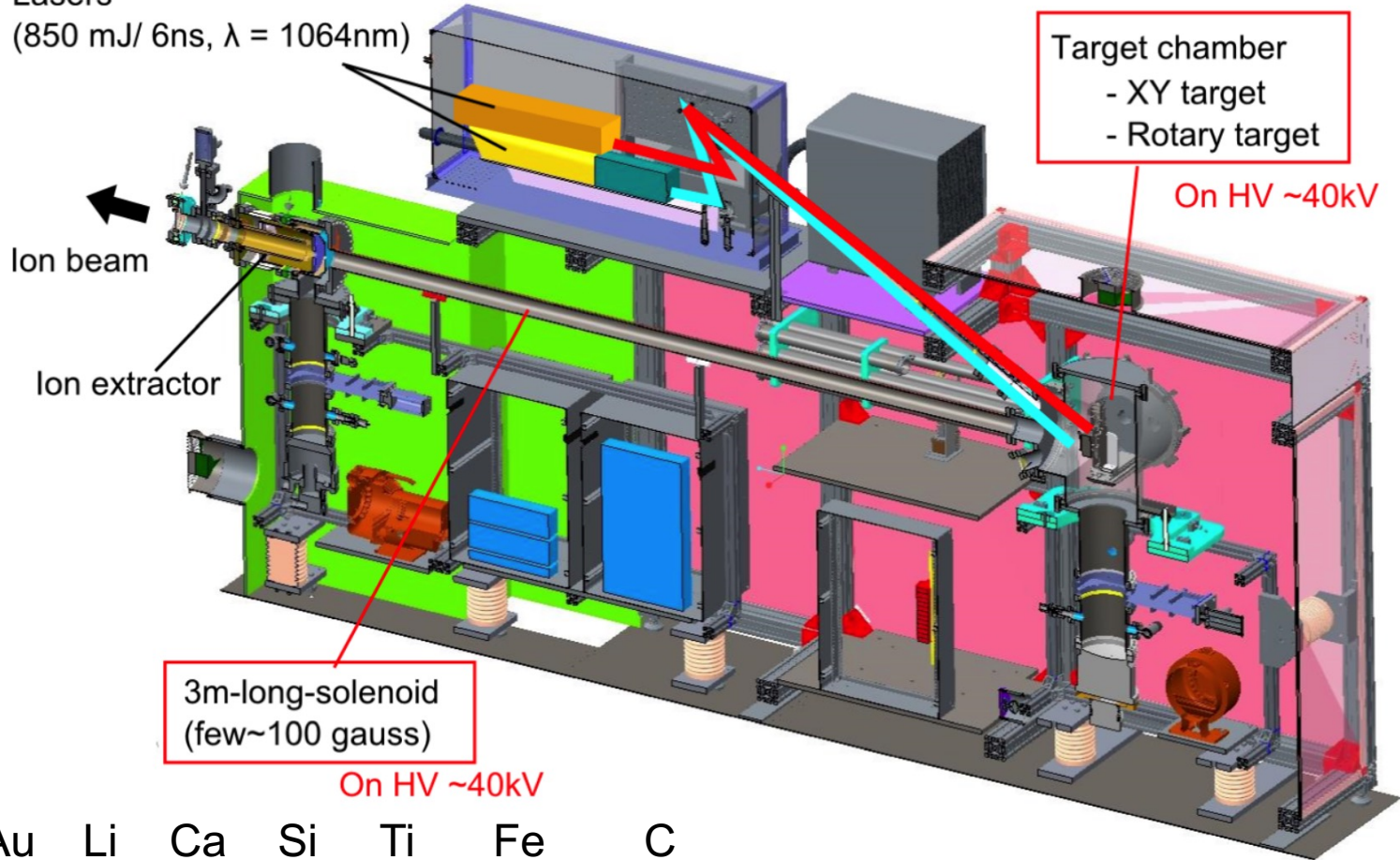
Laser ion source and electron beam ion source provide many types of ions to RHIC and NSRL from Li to Bi.



Laser ion source

Lasers

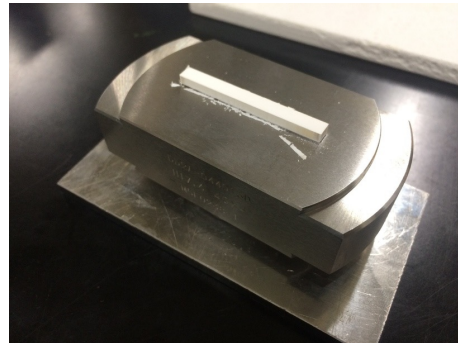
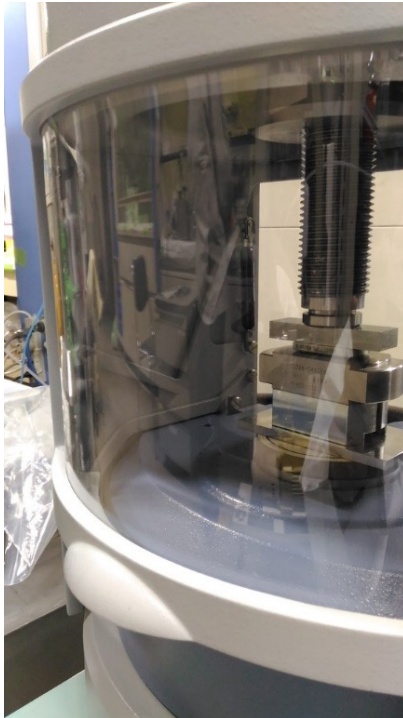
(850 mJ/ 6ns, $\lambda = 1064\text{nm}$)



Advantage of laser ion source :

- Any types of ions can be produced from solid material
- Fast species switch (within seconds, 130 switches/day)

Target development 1: Sintering oxide

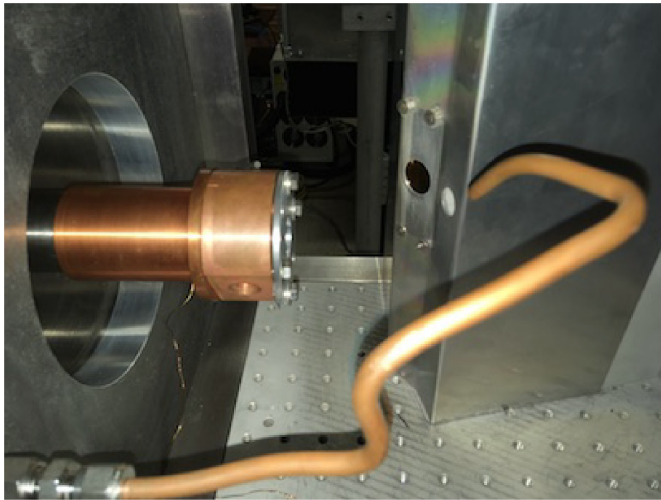


Developed to use powder of oxide of enriched Zr as a laser target

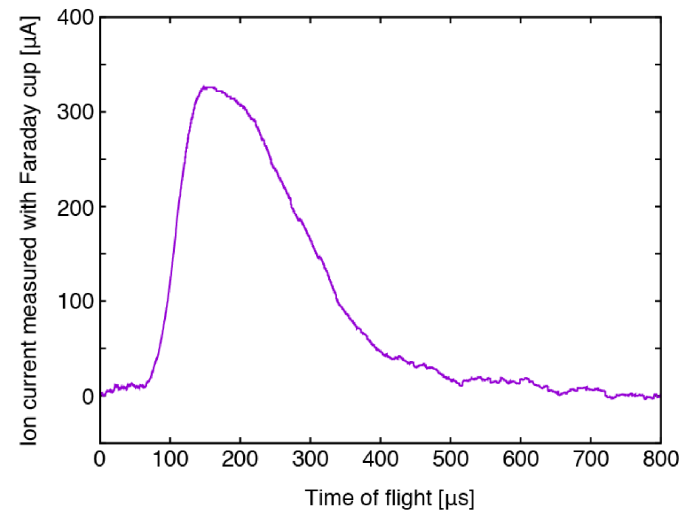
Target development 2: Cryotarget

Cold head (20K)

Nozzle for Xe gas

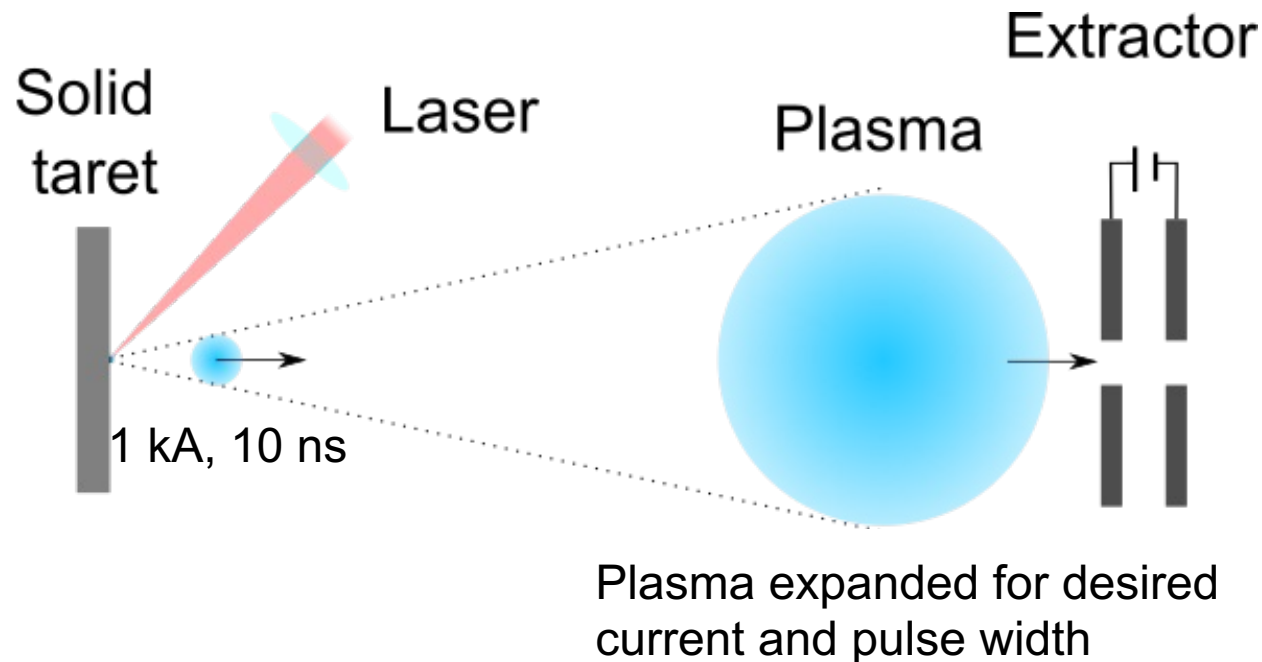


Enough beam current was produced



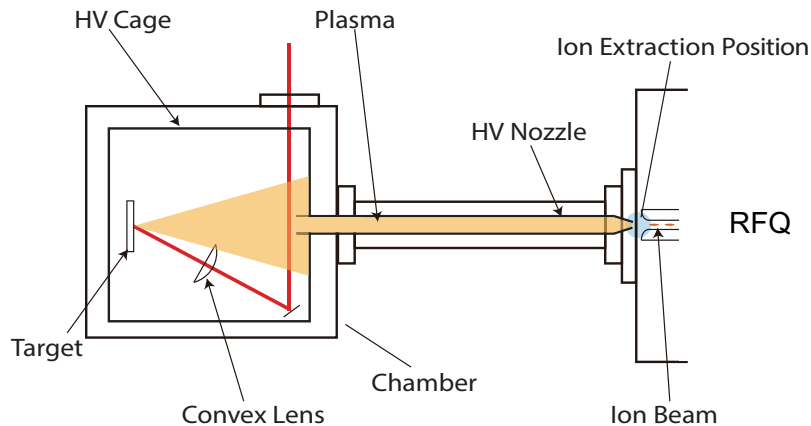
Under development to produce ions of gases

Intense pulsed beam of highly charged ions with focused laser pulse

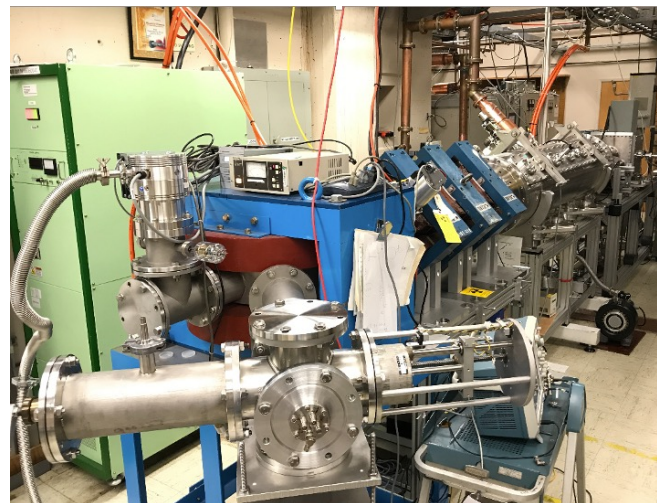


- Large number of ions ($10^{14} - 10^{15}$) are produced within laser pulse (<10 ns)
- Ions are emitted from point source \rightarrow low emittance

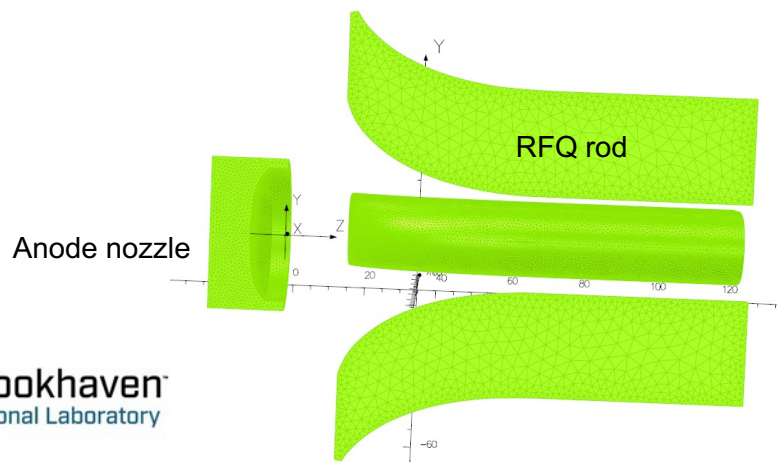
Intense pulsed beam production



Direct Plasma Injection Scheme



35 mA of ${}^7\text{Li}^{3+}$ was accelerated

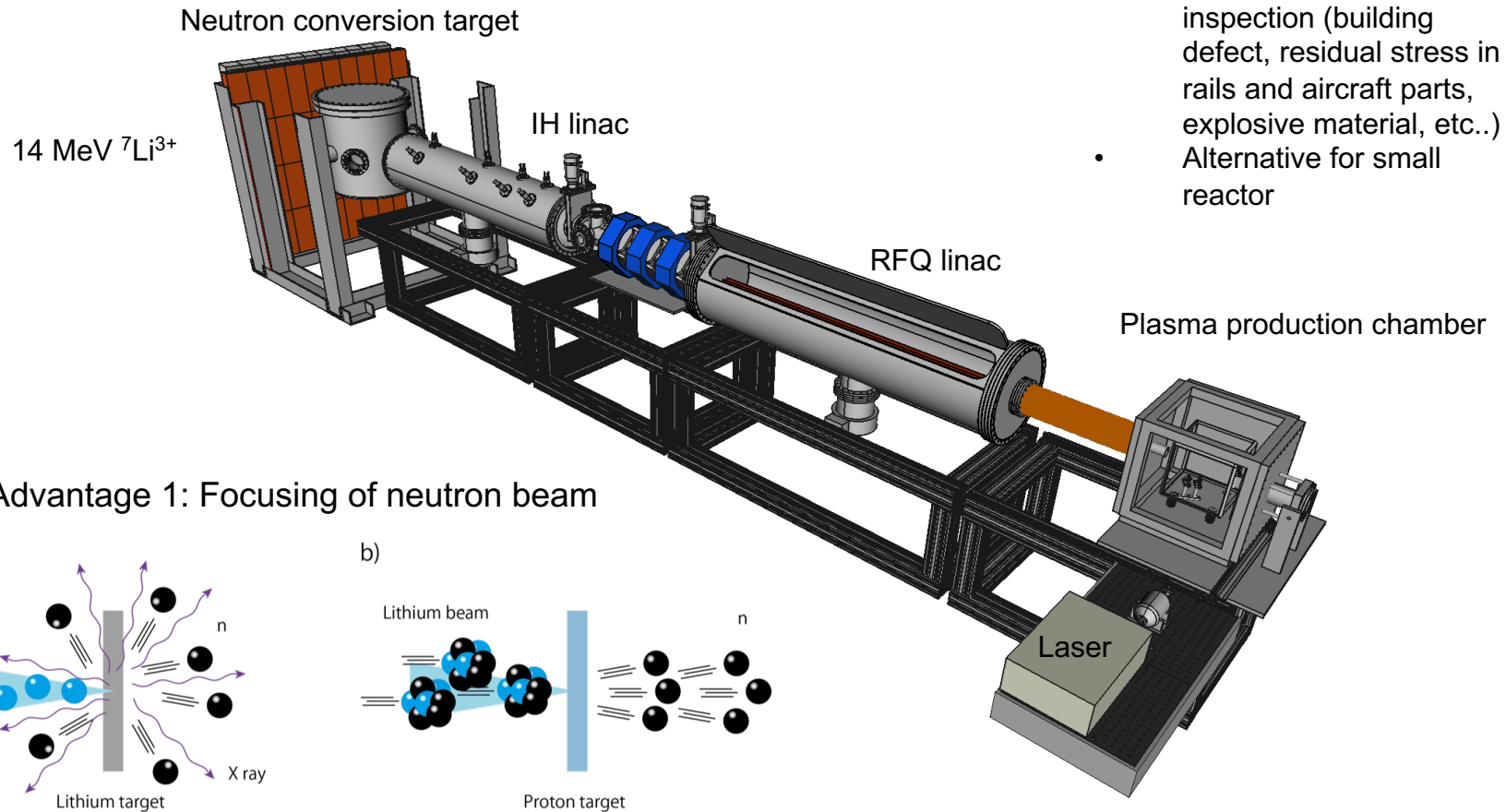


Simulation work is being performed to pursue large current. (300 mA acceleration suggested)

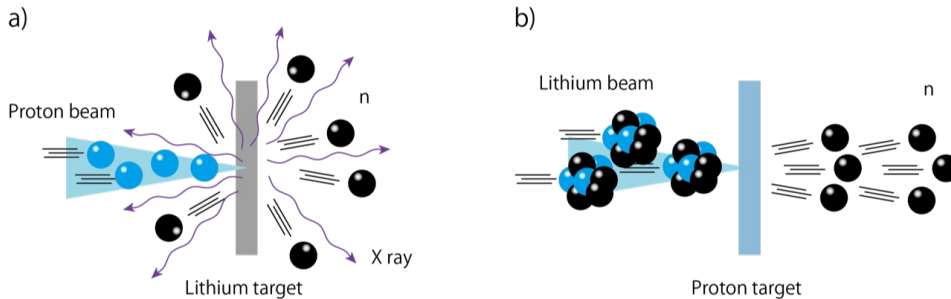
One application : Compact neutron source

Application:

- Nondestructive inspection (building defect, residual stress in rails and aircraft parts, explosive material, etc..)
- Alternative for small reactor



Advantage 1: Focusing of neutron beam



Advantage 2: Short beam pulse
Background can be separated by TOF method

Summary

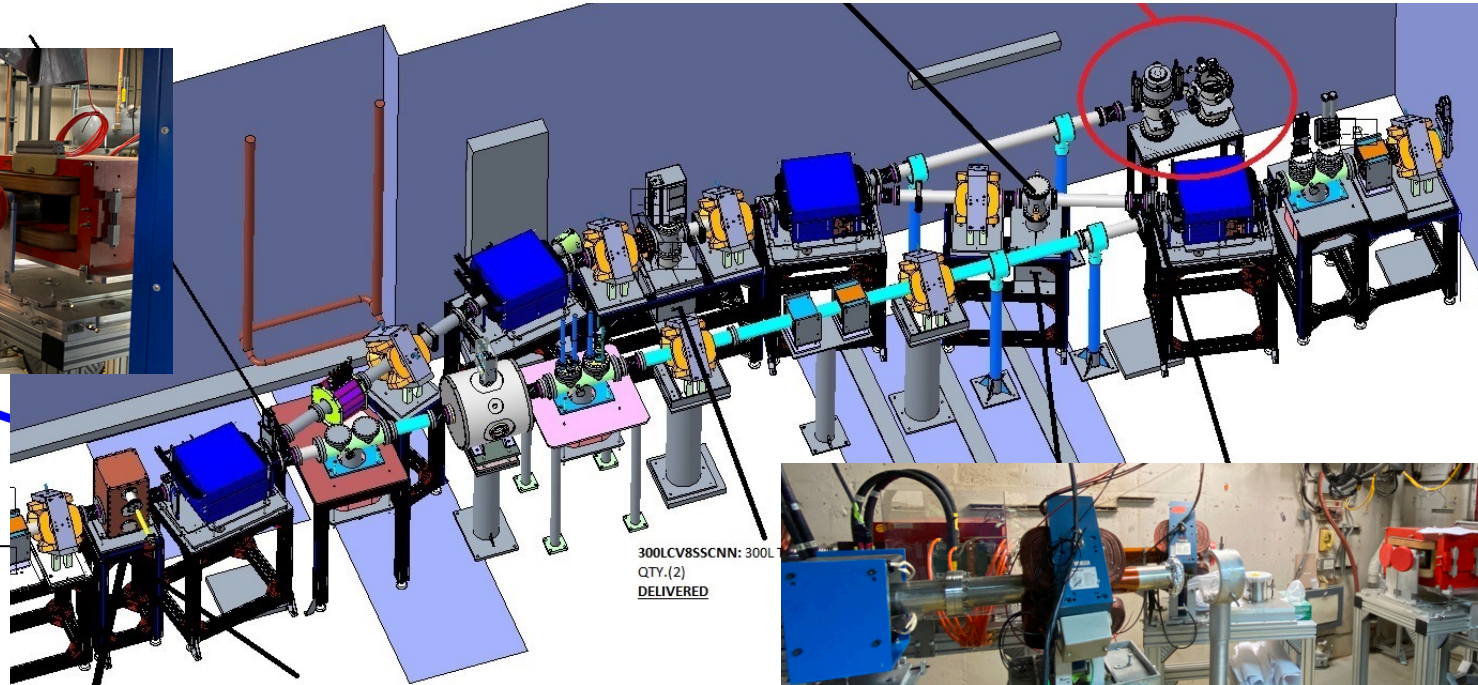
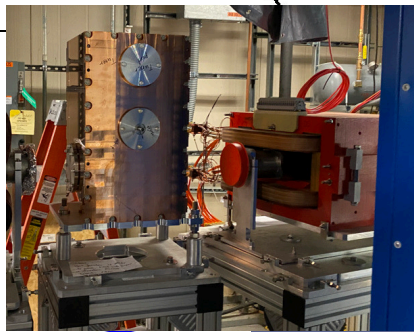
Laser ion sources have several features.

- All most all types of the ions can be produced from solid material.
- The species can be switched in short time.
- Intense pulsed beam can be produced.

Development continues to expand the ability and the application of laser ion sources.

Thank you

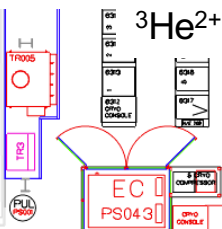
Pre-injector: LION and EBIS



Au^{32+} , Fe^{20+} , ...



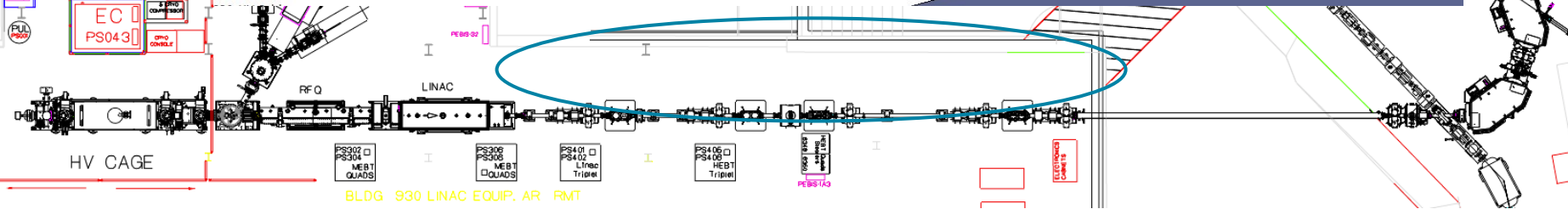
$^3He^{2+}$



CV-4V-SC-N-N: Gamma 45S Ion Pump
339: Controller

104220028 Cold Cathode, 2.75" conflat
103170024 Convection-pirani, 2.75" conflat.
ORDERED (Loralie)

300LCV8SSCNN: 300L
QTY.(2)
DELIVERED

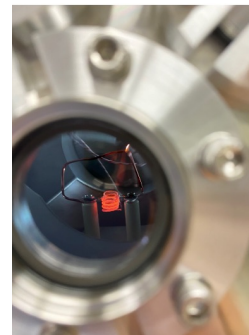
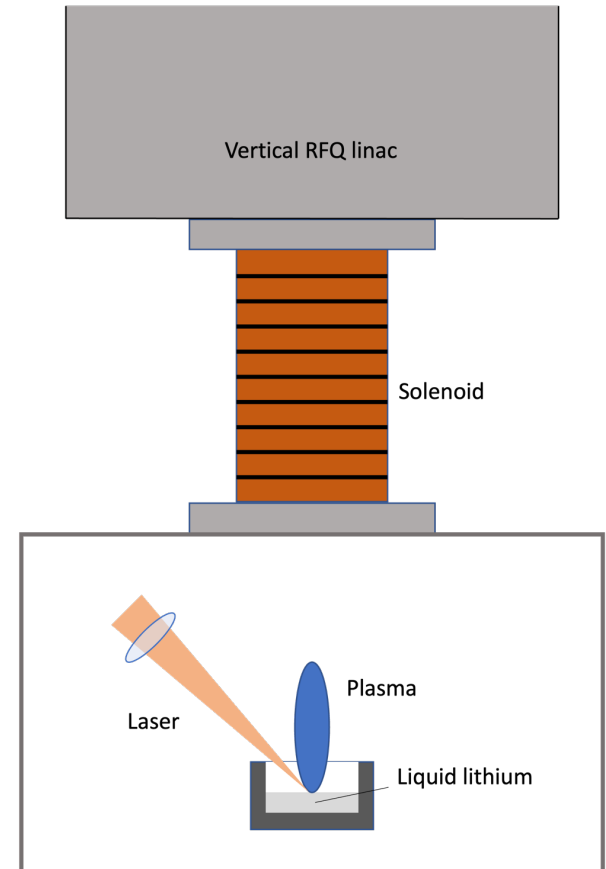


BLDG 930 LINAC EQUIP. AR RMT

Liquid target development to increase repetition rate



- Solid target should be moved every shot to provide a fresh surface -> large surface area is needed for high repetition rate.
- It is expected that the same spot can be used for liquid target.



Heating test